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APPLICANTS					
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** CONTINUING DATA **** <i>H. N. E. (U)</i>					
** FOREIGN APPLICATIONS **** <i>Y. H. (U)</i> REPUBLIC OF KOREA 2002-85460 12/27/2002					
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 01/05/2004					
Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged <i>[Signature]</i>	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>LV</i> Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 3	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
ADDRESS 04743 MARSHALL, GERSTEIN & BORUN LLP 233 S. WACKER DRIVE, SUITE 6300 SEARS TOWER CHICAGO, IL 60606					
TITLE Method of forming isolation film of semiconductor device					
FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:			<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)	